

Docket No.: 2336-241

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|---|---|---------------------------|
| In re Application of | : | |
| Je Won KIM et al. | : | Confirmation No. 2636 |
| Application No. 10/776,228 | : | Group Art Unit: 2812 |
| Filed: February 12, 2004 | : | Examiner: SAVITRI MULPURI |
| For: METHOD OF MANUFACTURING NITRIDE SEMICONDUCTOR LIGHT EMITTING DEVICE | | |

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

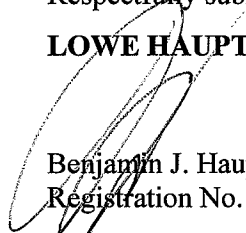
Dear Sir:

Applicant(s) hereby petition(s) the Commissioner of Patents and Trademarks to extend the time for response to the Official Action dated March 8, 2006 for 1 month from June 8, 2006 to July 8, 2006.

A credit card authorization form to cover the cost of the extension is attached. Any deficiency or overpayment should be charged or credited to Deposit Account No. 07-1337.

Respectfully submitted,

LOWE HAUPTMAN & BERNER, LLP


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DATE: July 10, 2006
BJH:KL/AYW